Conference News

INTERNATIONAL CONFERENCE ON SOLID FILMS AND SURFACES

To be held at Toshi Centre Hall, Tokyo, Japan. 6-8 July, 1978.

For further information please contact:

Professor R. Ueda
Department of Applied Physics
School of Engineering Science
Waseda University
4-170 Nishi-Ohkubo, Shinjuku-ku
TOKYO 160
Japan

FOURTH INTERNATIONAL THIN FILM CONGRESS

This will be held at the University of Technology, Loughborough, 11–15 September, 1978. The Congress is being organised by the Institute of Physics, London. The programme will be devoted mainly to discussion of the relationships between the electrical, magnetic, mechanical and optical properties of thin films and their crystalline, morphological, defect and compositional structure.

Both verbal and poster paper sessions will be held and also panel discussions, including exhibition topics. An exhibition of relevant equipment will be held.

This Congress follows the international conference on semiconductors, being held in Edinburgh on the 4-8 September, 1978, which is also being organised by the Institute of Physics, from which body further details may be obtained

300 word abstracts on A4 paper, suitable for photolitho reproduction, should be sent to the Congress Secretary:

Dr C. J. Todd Post Office Research Centre Martlesham Heath IPSWICH Suffolk. IP5 7RE U.K.

by 1 April, 1978. Manuscripts of accepted papers will be required by the 1 August, 1978. Please apply to the Congress Secretary, Dr C. J. Todd, for any further information.

8th EUROPEAN SOLID STATE DEVICES RESEARCH CONFERENCE

(in collaboration with the 3rd Symposium on Solid State Device Technology)

This will be held in Montpellier, France, 11–15 September, 1978 and will include device physics research plus material appropriate to solid state device technology. The scope will therefore be that of applied and fundamental research on solid state devices, including physical phenomena related to devices, solid state devices, device modelling and optoelectronic devices and also device technology associated with investigation of electronic materials and the technology of solid state devices. Requests for further information should be addressed to the Conference Secretary:

Prof. J. P. Nougier Université des Sciences et Techniques du Languedoc Centre d'Etudes d'Electronique des Solides 34060 MONTPELLIER Cedex FRANCE

1978 ISHM/US INTERNATIONAL MICRO-ELECTRONICS SYMPOSIUM

This will be held at the Radisson Hotel, Minneapolis, Minnesota, 25-27 September, 1978. Papers are solicited on work in the following fields:

Thick film materials and processes, device attachment and interconnection, packaging, reliability and failure analysis, design and specification criteria, new applications and manufacturing methods. For further information please contact:

Jerald M. Loy Mail Station MN 17-3636 Honeywell Inc. Avionics Division 2600 Ridgeway Parkway MINNEAPOLIS MN 55413 U.S.A.

HYBRID CIRCUITS, RELIABILITY, APPLICATIONS AND PRODUCTION TECHNIQUES

A two day meeting will be held in Milan, 5-6 October, 1978 on the above topics. Authors who wish to contribute papers should send a 300 word abstract as soon as possible, preferably before the 30 April, 1978, to the Secretariat at:

AEI — Sezione di Milano Gruppo di microelettronica P le R. Morandi 2-20121 MILANO Italy

ELECTRONICA 1978

9-15 November, 1978. To be held in Munich at the International Electronic Centre.

For further information please contact:

Herr H. J. Prieur Internationales Elektronik Zentrum D-8000 MUCHEN 12 Postfach 12 10 09 Theresienhöhe 13 Germany

1978 NATIONAL AMERICAN VACUUM SOCIETY SYMPOSIUM

This will be held in San Francisco 27 November— 1 December, 1978. Topics of interest and importance to device technologists are always presented at these meetings and for further information please contact:

> Paul Holloway or Jerry Nelson Sandia Laboratories Division 5825 ALBUQUERQUE N.M. U.S.A.

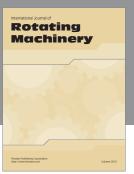
SECOND EUROPEAN HYBRID MICROELECTRONICS CONFERENCE

This will be held in Ghent, Belgium, 21–23 May, 1979. An equipment exhibition will be run in conjunction with the conference itself. For further details please contact the Conference Secretary:

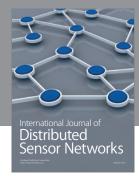
Professor R. Govaerts
President ISHM/Benelux
Instituut Elektrotechniek K U Leuven
Kardinaal Mercierlaan 94
B 3030 HEVERLEE
Belgium













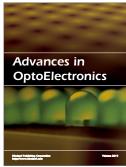




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